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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:

Gerard S. MOLONEY

Application No. 10/027,935

Filed: December 21, 2001

For: **Apparatus and Method for
Chemical-Mechanical Polishing
(CMP) Head Having Direct
Pneumatic Wafer Polishing
Pressure**

Examiner: ELY, TIMOTHY V

Art Unit: 3724

Confirmation No.: 2631

Attorney Docket No. A-68359-1/RMA/JJZ

Dated: March 2, 2005

Certificate of Mailing

I hereby certify that this correspondence is being deposited in the United States Mail, postage prepaid in an envelope addressed to Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on March 2, 2005.

By: 

Lori Cox

RESPONSE/AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment is made in response to the Office Action mailed December 2, 2004.

Amendment to the Specification begins on page 2 of this paper.

Amendment to the Claims begins on page 4 of this paper.

Remarks/Arguments begin on page 12 of this paper.

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